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Docket No. 0756-958

RESPONSE UNDER 37 CFR 1.116 - EXPEDITED

PROCEDURE - EXAMINING GROUP 1104

#38/Chw
9-26-97

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

Shunpei YAMAZAKI et al.

Serial No. 08/183,800

Filed: January 21, 1994

For: SEMICONDUCTOR MATERIAL

AND METHOD FOR FORMING

THE SAME AND THIN FILM

TRANSISTOR

RECEIVED

SEP 16 1997

GROUP 1100

) Examiner S. Crane

) Art Unit: 2508

RECEIVED

SEP 24 1997

GROUP 2500

) September 10, 1997

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on September 10, 1997.

Ingeborg J. Alexander
Ingeborg J. Alexander

AMENDMENT AFTER FINAL

Honorable Assistant Commissioner for Patents

BOX AF

Washington, D.C. 20231

Sir:

In response to the Office Action mailed June 10, 1997, please amend the above-identified application as follows.

IN THE CLAIMS:

Please amend claims 32, 36, 37 and 38 as follows:

32. (Four Times Amended) A thin film transistor produced by a process comprising the steps of:

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